

## ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18 Stylesheet Version v18.0

> Title of Invention

MODIFIED TRANSFER FUNCTION DEPOSITION BAFFLES AND HIGH DENSITY PLASMA IGNITION THEREWITH IN SEMICONDUCTOR PROCESSING

Application Number:

10/080496

Confirmation Number:

8492

First Named Applicant:

Attorney Docket Number: TAZ213

Jozef Brcka

Art Unit:

1763

Examiner:

Luz L.

Search string:

(6287435).pn.

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That each item of information contained in the information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement.

## **US Patent Documents**

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	6287435	2001-09-11	Drewery et al.			

## Signature

Examiner Name	Date



## Electronic Filing System (EFS) Data Electronic Patent Application Submission USPTO Use Only

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**GROUP 1700** 

EFS ID:

45389

Application ID:

10080496

MODIFIED TRANSFER FUNCTION

**DEPOSITION BAFFLES AND HIGH** 

Title of Invention:

**DENSITY PLASMA IGNITION** 

THEREWITH IN SEMICONDUCTOR

**PROCESSING** 

First Named Inventor:

Jozef Brcka

Domestic/Foreign Application:

**Domestic Application** 

Filing Date:

2002-02-22

**Effective Receipt Date:** 

2003-08-12

**Submission Type:** 

Information Disclosure Statement

Filing Type:

Confirmation number:

8492

**Attorney Docket Number:** 

**TAZ213** 

Total Fees Authorized:

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Submitted by:	Elec. Sign.	Sign. Capacity
Joseph R. Jordan Registered Number: 25,686	Joseph R. Jordan	Attorney

Documents being submitted

Files

us-ids

TAZ213-usidst.xml

us-ids.dtd

us-ids.xsl

Comments